

## Inventor Information

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## Application Information

Title Line One:: METHOD AND APPARATUS FOR ION  
Title Line Two:: ATTACHMENT MASS SPECTROMETRY  
Total Drawing Sheets:: 10  
Docket Number:: 109675

## Prior Foreign Applications

Foreign Application One:: 2000-169644  
Filing Date:: June 6, 2000  
Country:: JAPAN  
Priority Claimed:: YES

## Assignee Information

Name of assignee:: ANELVA CORPORATION  
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